

Notice of References Cited

Application/Control No.

10/814,697

Applicant(s)/Patent Under
Reexamination
SHI ET AL.

Examiner

Anna L. Verderame

Art Unit

1795

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,828,558	12-2004	Arnone et al.	250/341.1
*	B	US-2003/0152739	08-2003	Yamamoto et al.	428/64.4
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	WO 00/75641	12-2000	WO	Arnone et al.	
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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	X	

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